

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AF
8723
JW

Applicant: Paul A. Farrar

Title: CHEMICAL MECHANICAL POLISHING SYSTEM AND PROCESS

Docket No.: 1303.018US1

Filed: August 30, 2001

Examiner: Maurina Rachuba



Serial No.: 09/944,983

Due Date: June 23, 2005

Group Art Unit: 3723

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ A return postcard.

☒ An Amendment and Response Under 37 CFR 1.116--Expedited Procedure (23 Pages).

If not provided for in a separate paper filed herewith, Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: Marvin L. Beekman

Atty: Marvin L. Beekman

Reg. No. 38,377

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 4 day of May, 2005.

Name

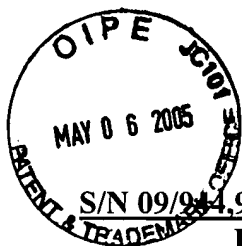
KACIA LEE

Signature

Kacia Lee

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



EXPEDITED PROCEDURE – EXAMINING GROUP 3723

S/N 09/944,983

PATENT

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AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed March 23, 2005, please amend the application as follows: